

Notice of References Cited	Application/Control No. 10/649,311	Applicant(s)/Patent Under Reexamination BASCERI ET AL.	
	Examiner Jennifer M. Kennedy	Art Unit 2812	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al. Silicon Processing for the VLSI Era, Volume 1- Process Technology, Second Edition, 2000, Lattice Press, pages 657-658
	V	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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